



Docket No.: 8733.154.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jin Jang, et al.

Confirmation No.: 7883

Application No.: 09/350,313 ✓

Group Art Unit: 1765

Filed: July 9, 1999

Examiner: R. Kunemund

For: METHOD OF CRYSTALLIZING
AMORPHOUS SILICON LAYER AND
CRYSTALLIZING APPARATUS THEREOF

Customer No.: 30827

SUPPLEMENTAL AMENDMENT

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Advisory Action dated March 24, 2004 (Paper No. 20040322),
please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins
on page 2 of this paper.

Remarks begin on page 7 of this paper.